

Dear Sir:

Pursuant to the duty of disclosure provided by 35 C.F.R. § 1.56 and §§ 1.97-98, the applicants wish to make the following references and information of record in the above-identified application. Copies of the cited references are enclosed. The references are also listed in the PTO-1449 form enclosed herewith. It is requested that the references and information be given careful consideration and that they be cited of record in the prosecution history of the present application so that they will appear on the face of the patent issuing from the present application.

In the judgment of the undersigned, portions of the references may be material to the examination of the pending claims. However, the references have not been reviewed in sufficient detail to make any other representation and, in particular, no representation is intended as to the relative importance of any portion of the references. This Statement is not a representation that the

cited references have effective dates early enough to be "prior art" within the meaning of 35 U.S.C.

§§ 102 or 103.

CITED REFERENCES

Name

SEP 1 0 2002
TECHNOLOGY CENTER R3700

U.S. Patents:

Document Number

1

Date

- 1. U.S. Patent 6,318,994, Chishti et al., issued November 20, 2001
- 2. U.S. Patent 6,334,853, Kopelman et al., issued January 1, 2002
- 3. U.S. Patent 6,371,761, Cheang et al., issued April 16, 2002
- 4. U.S. Patent 6,386,878, Pavlovskaia et al., issued May 14, 2002

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Technology Center 2100

Classification

Respectfully submitted.

McDonnell Boehnen Hulbert & Berghoff

Date:

By:

Thomas A. Fairhall

Reg. No. 34,591

CERTIFICATE OF MAILING

The undersigned hereby certifies that the foregoing INFORMATION DISCLOSURE STATEMENT is being deposited as first class mail, postage prepaid, in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231 on this ______ day of _______ and _______.

Thomas A Fairhall

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FORM PTO-1449 (Rev. 2-32)	U.S. Department of Commerce Patent and Trademark Office		Serial No.
OIPE	INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	01-101	09/834,413
JUN 0 6 2002	JUN 1 2 2002	Applicant: Rudger Rubbert et al	
JUN U 6 ZUUZ	TECHNOLOGY CENTER R3700	Filing Date: 04/13/01	Group : 3732
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U.S. PATENT DOCUMENTS SEP 1 6 2002

Examiner Initial	Document Number	Date	Technology Center	r 2100 Class	Subclass	Filing Dat if Appropriate		
	6,318,994	11/20/01	Chishti et al.	433	24	<u> </u>		
	6,334,853	01/01/02	Kopelman et al.	600	590	CH2		
	6,371,761	04/16/02	Cheang et al.	433	24	SEP DIO		
	6,386,878	05/14/02	Pavlovskaia et al.	433	215	1		
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FOREIGN PATENT DOCUMENTS

	Do	cum	nent N	lumbe	er	Date		Country	Class	Subclass	Translation		
											Yes	No	

	 OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).	
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EXAMINER DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

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